

EV18261155

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/536,037  
Filing Date .... March 27, 2000  
Inventor .... Weimin (Michael) Li  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 2822  
Examiner .... T. Thomas  
Attorney's Docket No. .... MI22-1398  
Title: Low k Interlevel Dielectric Layer Fabrication Methods



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To: Box RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

**References -- See Attached Form PTO-1449**

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to ensure consideration of the references listed on the attached form PTO-1449.

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

Respectfully submitted,

Dated: Nov. 8, 2002

By: \_\_\_\_\_

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Reg. No. 36,138

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Box GROUP ART UNIT 2822  
Assistant Commissioner for Patents  
Washington, D.C. 20231

**REMARKS**

The Examiner's attention is directed to the reference which is listed on the attached Form PTO-1449 and copy of which is attached. No admission is made regarding whether all the submitted references are prior art.

Citation of this patent is respectfully requested.

This Information Disclosure Statement is being filed within three months of the filing date of the Request For Continued Examination (RCE) filed August 31, 2001. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Date: Nov 15, 2001

By: Bernard Berman

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200 Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
M122-1398SERIAL NO.  
09/536.037LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Weimin Li et al.FILING DATE  
March 27, 2000GROUP  
2822

## U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	5,801,399	9/98	Hattori et al.			
AB	5,994,730	11/99	Shrivastava et al.			
AC	6,040,619	3/00	Wang et al.			
AD	6,060,765	5/00	Maeda			
AE	6,060,766	5/00	Mehta et al.			
AF	6,133,613	10/00	Yao et al.			
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EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.